

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Case No. 07-1233-US)**

In the Application of:	)	
	)	
<b>Terry L. Alford, et al.</b>	)	
	)	Examiner: <b>Stanetta D. Isaac</b>
Serial No.: <b>10/579,051</b>	)	
	)	Group Art Unit: <b>2812</b>
Filing Date: <b>May 9, 2006</b>	)	
	)	Confirmation No.: <b>6367</b>
For: <b>Flexible Electronics Using Ion Implantation</b>	)	
<b>to Adhere Polymer Substrate to Single</b>	)	
<b>Crystal Silicon Substrate</b>	)	

BOX: AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION, MAILED DECEMBER 4, 2008**

Dear Sir,

Please consider the following amendments and remarks in response to the Office Action mailed December 4, 2008. No fee is believed to be due in connection with this filing. However, if additional fees are due the Commissioner is authorized to charge our deposit account number 13-2490.

**Amendments to Claims** begin on page 2 of this paper

**Remarks** begin on page 4 of this paper